

**REMARKS**

Claims 1, 4, 9, 10 and 17-19 are pending in this application. By this Amendment, claims 1 and 18 are amended. No new matter is added by this Amendment. Support for the language added to claims 1 and 18 is found in Fig. 4.

Entry of the amendments is proper under 37 CFR §1.116 since the amendments: (a) place the application in condition for allowance for the reasons discussed herein; (b) do not raise any new issue requiring further search and/or consideration as the amendments merely further clarify the subject matter of the claims and amplify issues previously discussed throughout prosecution; (c) do not present any additional claims without canceling a corresponding number of finally rejected claims; and (d) place the application in better form for appeal, should an appeal be necessary. The amendments are necessary and were not earlier presented because they are made in response to arguments raised in the final rejection. Entry of the amendments is thus respectfully requested.

**I. Allowable Subject Matter**

Applicant thanks the Examiner for the indication that claim 9 is allowed.

**II. Rejection Under 35 U.S.C. §102**

Claims 1, 4, 10 and 17-19 are rejected under 35 U.S.C. §102 over Japanese Application No. 11-97699 (Shigeki). This rejection is respectfully traversed.

Claims 1 and 18 recite that the sub gate electrode is disposed so as to cover at least one end of the semiconductor film and so as to cover at least an entire width of the gate electrode.

Shigeki discloses a sub gate electrode. However, Shigeki fails to teach or suggest that the sub gate electrode is disposed so as to cover at least one end of the semiconductor film and so as to cover at least an entire width of the gate electrode.

Accordingly, Shigeki fails to anticipate the subject matter of claims 1 and 18, as well as the claims dependent therefrom.

Withdrawal of the rejection is respectfully requested.

**III. Conclusion**

In view of the foregoing, it is respectfully submitted that this application is in condition for allowance. Favorable reconsideration and prompt allowance of the pending claims are earnestly solicited.

Should the Examiner believe that anything further would be desirable in order to place this application in even better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,



James A. Oliff  
Registration No. 27,075

Linda M. Saltiel  
Registration No. 51,122

JAO:LMS/eks

Date: December 20, 2005

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461